Docket No.: 0171-1079PUS1 (PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Hiroki YOSHIKAWA et al.

Confirmation No.: 003156

Filed: March 30, 2004 Art Unit: 1756

For: PHOTOMASK BLANK, PHOTOMASK, AND Examiner: S. D. Rosasco

METHOD OF MANUFACTURE

## AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandría, VA 22313-1450

Application No.: 10/811,924

Sir:

## INTRODUCTORY COMMENTS

In response to the Office Action dated October 20, 2006, please amend the aboveidentified U.S. patent application as follows:

Remarks/Arguments begin on page 2 of this paper.